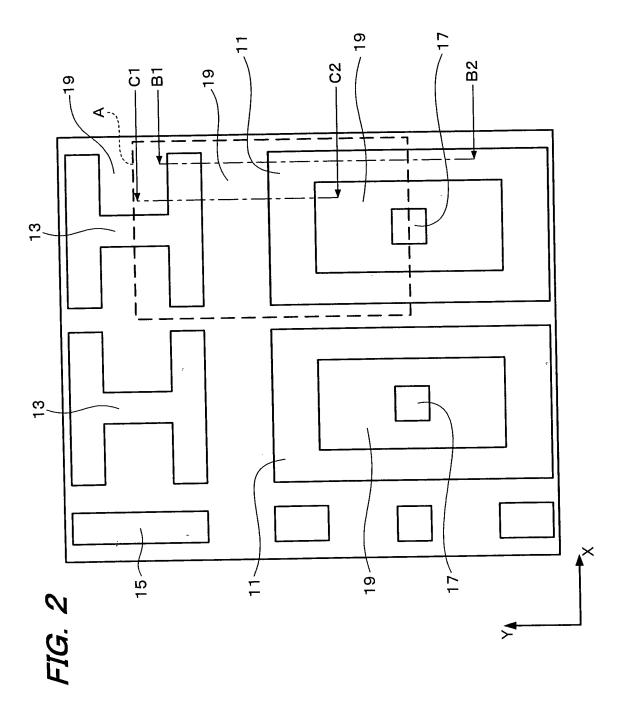
\_31a \_31b -21a 43 A 23 23 Š Š ö á 4<u>1</u>a FIG. 1



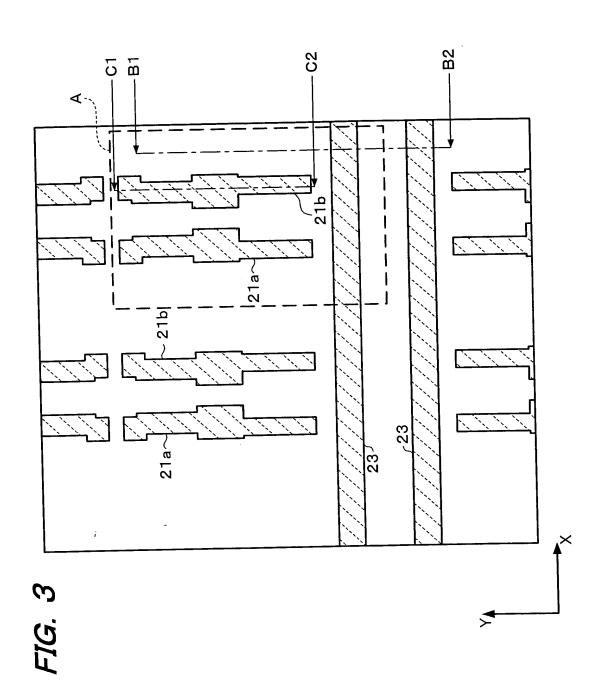
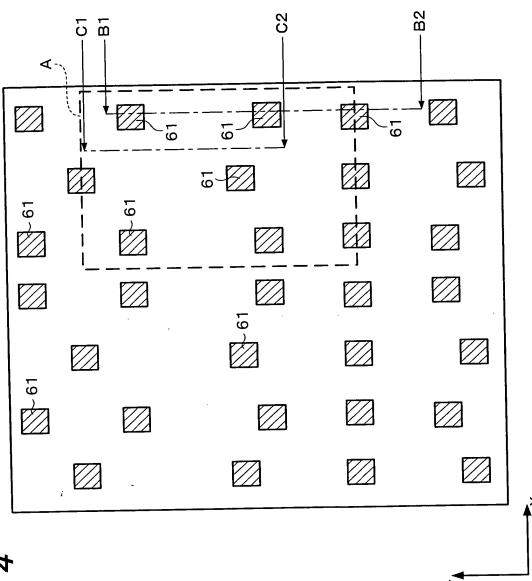


FIG. 4



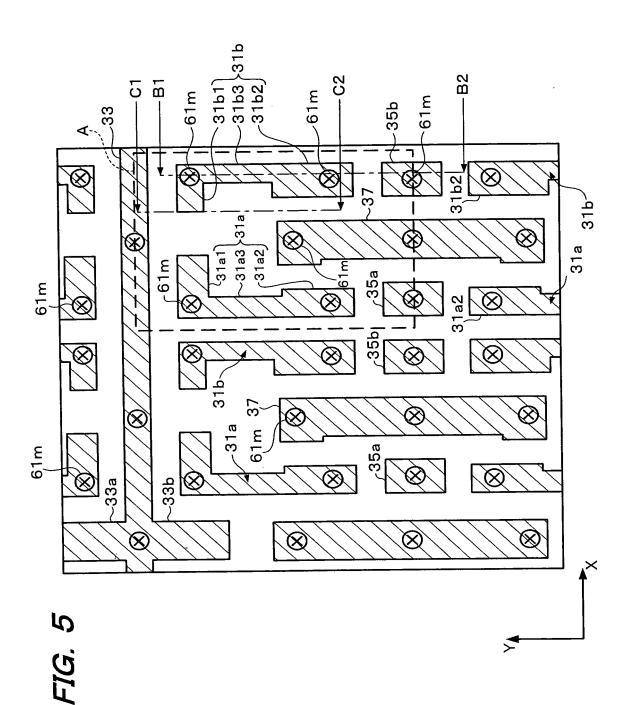


FIG. 6

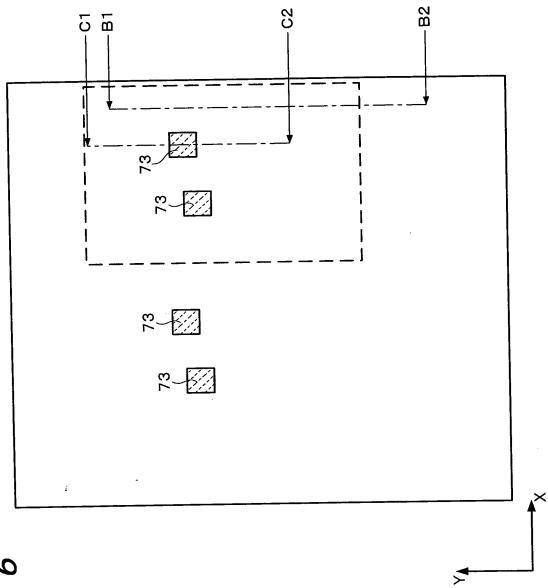
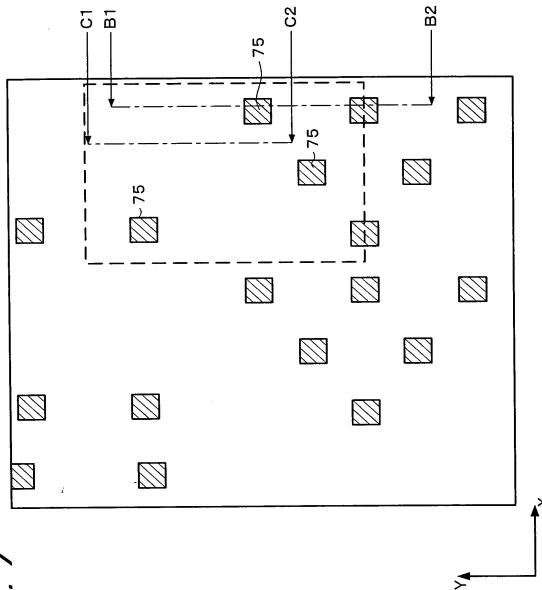
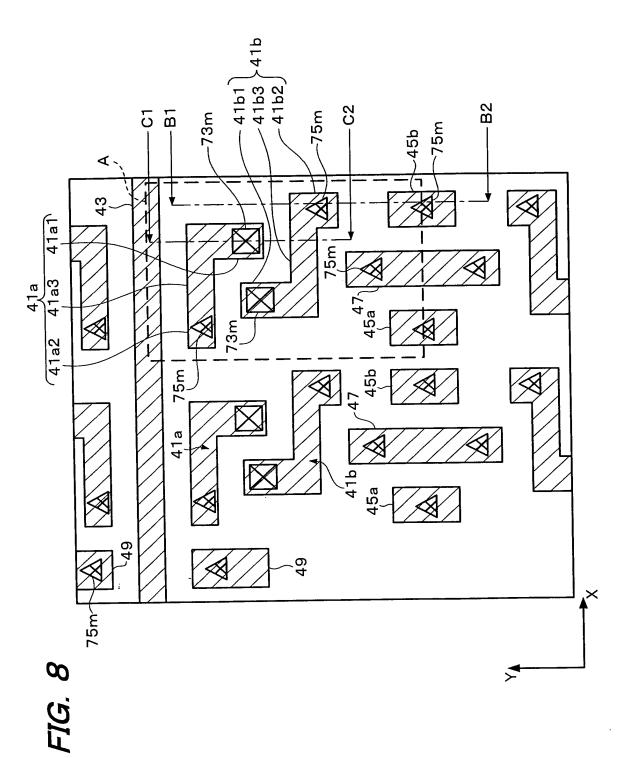
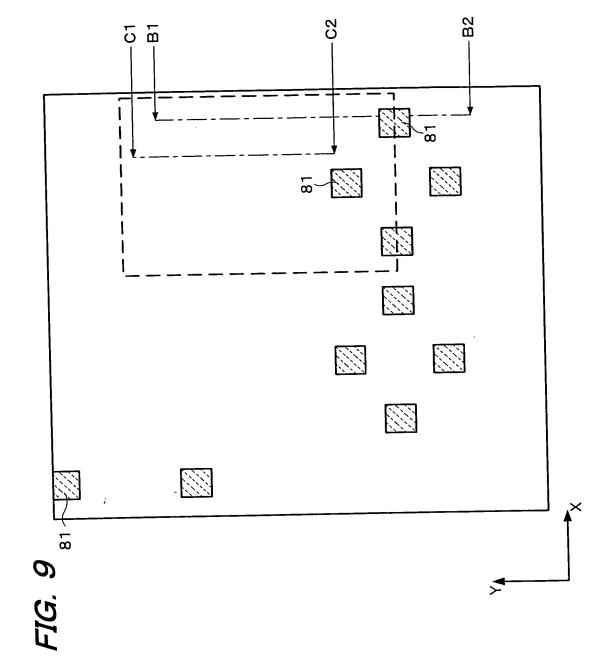
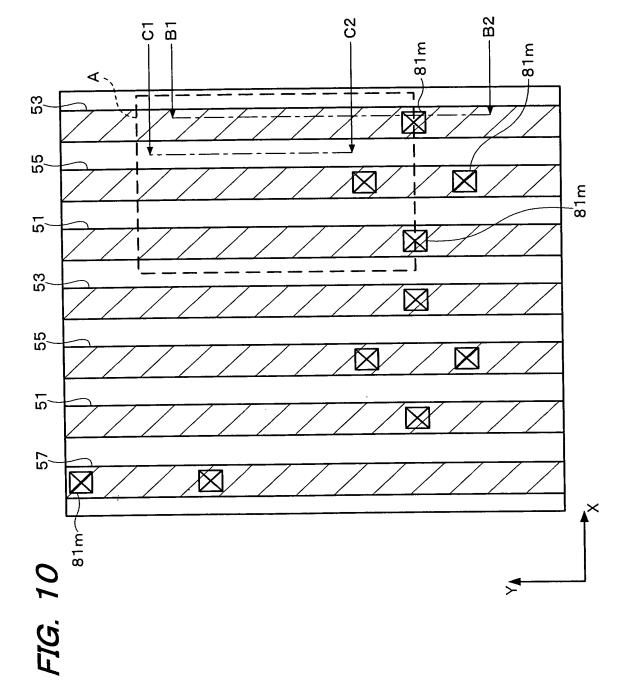


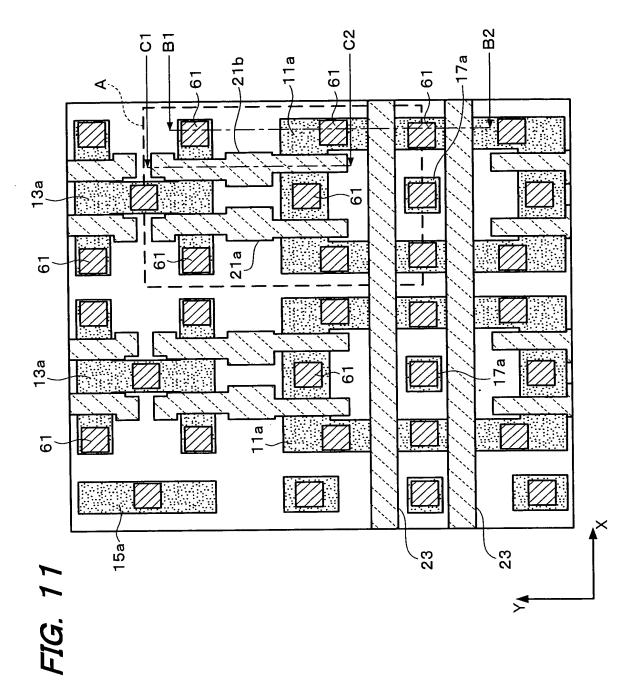
FIG. 7











3<u>1</u>a FIG. 12

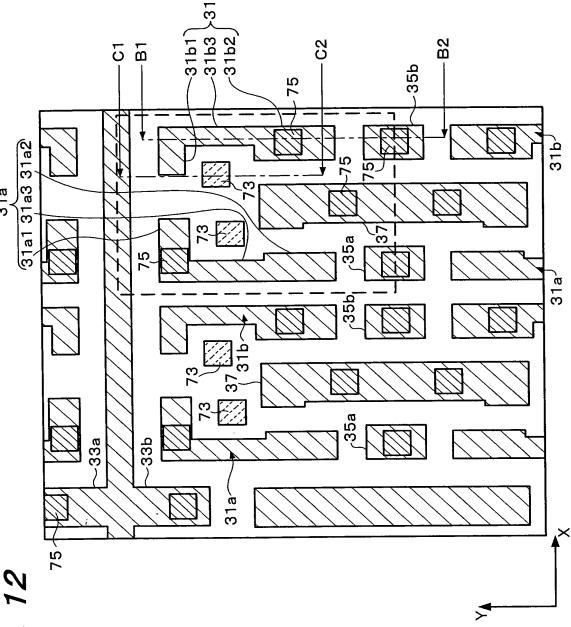


FIG. 13

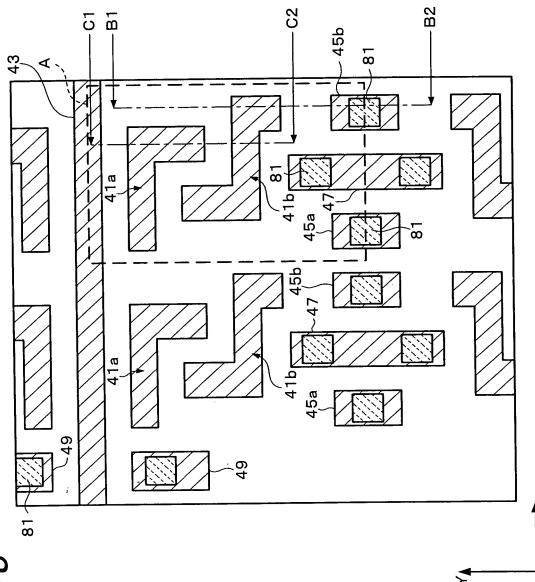


FIG. 14

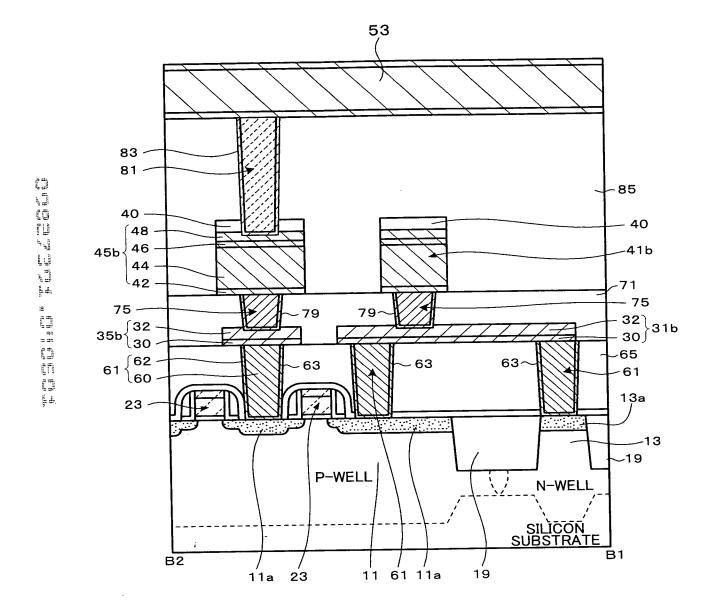
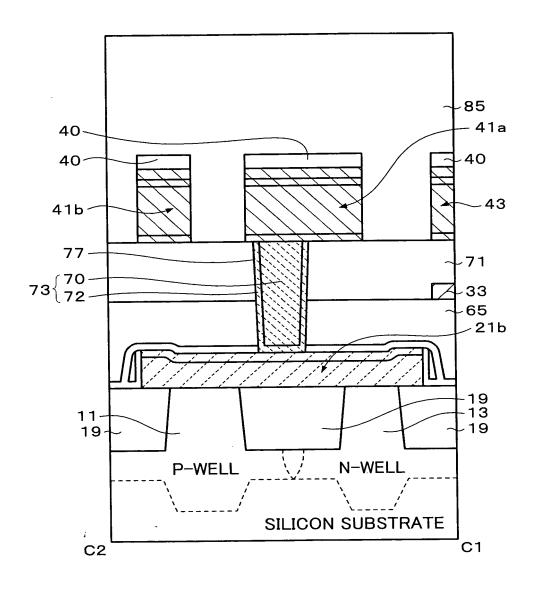


FIG. 15



- 71 - 31b . 82 75 161 194 - 53 8 SILICON SUBSTRATE P-WELL 23 B2 , 23-75 35b. 45b-6 <del>~</del> 83 , 65 -91 82 87 7 95 . 93 -81 9 P-WELL 100 100 25 FIG. 16 191 106 96 81 871 92 -1 68 94

FIG. 17

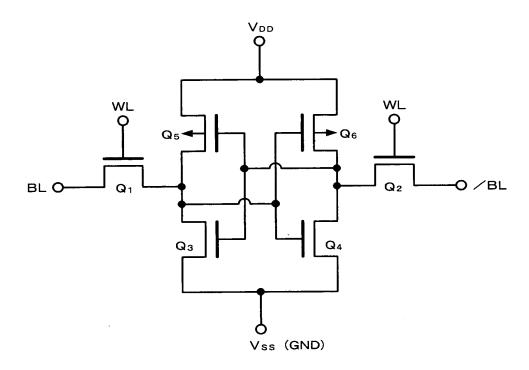


FIG. 18

